

INFORMATION DISCLOSURE CITATION IN AN APPLICATION

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APPLICANT
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U.S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

OTHER ART (Including Author, Title, Date, Pertinent Pages, Etc.)

TVP	U.S. Patent Application Serial Number 09/466,934, Filed December 20, 1999 <i>Allowed 8/12/01</i>
TVP	U.S. Patent Application Serial Number 09/639,953, Filed August 17, 2000 <i>US Pat. 6,495,898</i>
TVP	U.S. Patent Application Serial Number 09/677,881, Filed October 3, 2000 <i>US Pat. 6,455,894</i>
TVP	Hirano, et al., "Bulk-Layout-Compatible 0.18 μ m SOI-COS Technology Using Body-Fixed Partial Trench Isolation (PTI)" Proceedings of 1999 IEEE International SOI Conference, October 1999, pages, 131 - 132
TVP	Maeda, et al., "Analysis of Delay Time Instability According to the Operating Frequency in Field Shield Isolated SOI Circuits" Proceeding of IEEE Transactions of Electron Devices, Vol. 45, No.7, July 1998, pages 1479 - 1486
EXAMINER <i>John Mark</i>	DATE CONSIDERED <i>12/03/02</i>

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.